



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG828647403
Report verification at igi.org

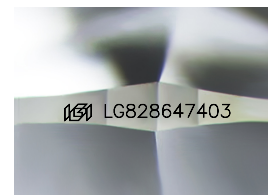
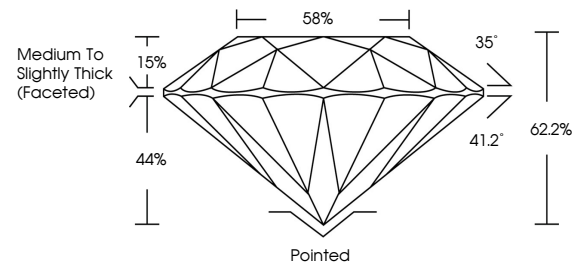
August 21, 2026	
IGI Report Number	LG828647403
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.11 - 8.15 X 5.06 MM
GRADING RESULTS	
Carat Weight	2.05 CARATS
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG828647403

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

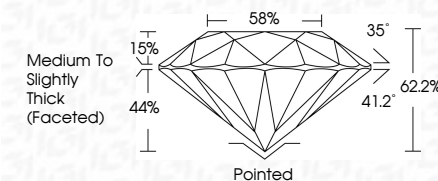
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

August 21, 2026	
GJ Report No. LG928647403	
ROUND BRILLIANT	
Color Grade	2.05 CARATS
Clarity Grade	VVS 2
Cut Grade	IDEAL
Depth	62.2%
Table	86%
Girdle	Medium to Slightly Thick (Faceted)
Culet	Poished
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscriptions(s)	1691 LG928647403

Comments:
 Created by Chemtary Group Diamond was
 treated by Chemical Vapor Deposition
 CVD growth process.
 type IIA